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RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
GROUP ART UNIT 1765

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/085,128

Confirmation No.: 2733

In re Application of:

Kiyoshi ARITA et al.

Group Art Unit: 1765

Filed: March 1, 2002

Examiner: Duy Vu Nguyen Deo

For: PLASMA PROCESSING METHOD

*OK to*  
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AMENDMENT UNDER 37 CFR §1.116

MAIL STOP AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action mailed September 7, 2004,  
please amend the above-identified application as follows: